Non-destructive measurement of photoexcited carrier transport in graphene with ultrafast grating imaging technique

Ke Chen a, b, Maruthi Nagavalli Yogeesh c, Yuan Huang d, Shaoqing Zhang b, Feng He b, e, Xianghai Meng b, Shaoyin Fang a, Nathianial Sheehan c, Tiger Hu Tao b, Seth R. Bank c, Jung-Fu Lin f, g, Deji Akinwande c, Peter Sutter h, Tianshu Lai a, **, Yaguo Wang b, e, *

a State-Key Laboratory of Optoelectronic Materials and Technologies, School of Physics and Engineering, Sun Yat-Sen University, Guangzhou, Guangdong 510275, China
b Department of Mechanical Engineering, The University of Texas at Austin, Austin, TX 78712, USA
c Department of Electrical and Computer Engineering, Microelectronics Research Center, The University of Texas at Austin, Austin, TX 78758, USA
d Center for Functional Nanomaterials, Brookhaven National Lab, Upton, NY 11973, USA
e Texas Materials Institute, The University of Texas at Austin, Austin, TX 78712, USA
f Department of Geological Sciences, Jackson School of Geosciences, The University of Texas at Austin, Austin, TX 78712, USA
g Center for High Pressure Science and Technology Advanced Research (HPSTAR), Shanghai 201900, China
h Department of Electrical & Computer Engineering, University of Nebraska-Lincoln, Lincoln, NE 68588, USA

A R T I C L E   I N F O
Article info
Article history:
Received 24 March 2016
Received in revised form 23 May 2016
Accepted 31 May 2016
Available online 1 June 2016

A B S T R A C T
Graphene has great potential for fabrication of ultrafast opto-electronics, in which relaxation and transport of photoexcited carriers determine device performance. Even though ultrafast carrier relaxation in graphene has been studied vigorously, transport properties of photoexcited carriers in graphene are largely unknown. In this work, we utilize an ultrafast grating imaging technique to measure lifetime ($\tau_r$), diffusion coefficient (D), diffusion length (L) and mobility (µ) of photoexcited carriers in mono- and multi-layer graphene non-invasively. In monolayer graphene, $D \approx 10,000 \text{ cm}^2/\text{s}$ and $\mu \approx 120,000 \text{ cm}^2/\text{V}\cdot\text{s}$ have been observed, both of which decrease drastically in multilayer graphene, indicating that the remarkable transport properties in monolayer graphene originate from its unique Dirac-Cone energy structure. Mobilities of photoexcited carriers measured here are several times larger than the Hall and Field-Effect mobilities reported in literature ($<15,000 \text{ cm}^2/\text{V}\cdot\text{s}$), due to the high energy of photoexcited carriers. Our results indicate the importance of obtaining monolayer graphene to realize high-performance graphene devices, as well as the necessity to use transport properties of photoexcited carriers for predicting the performance of graphene-based opto-electronics.

© 2016 Elsevier Ltd. All rights reserved.

1. Introduction

Graphene has great potential application in high-speed electronics due to its unique electronic properties. Carrier transport properties, such as mobility $\mu$ and diffusion length $L$ determine performance of graphene devices. Electrons in graphene have been found to possess ultrahigh carrier mobility under an external electric field [1–4]. Historically, carrier mobility used for electronics is usually measured via the Hall Effect, where a magnetic field is used to detour electrons [5]. For graphene-based Field-Effect transistors, Field-Effect mobility is used, where the source-drain current is measured under a gate voltage, either at linear or saturation regions [6]. Both aforementioned methods are environmental-temperature static measurements and deposition of electrodes is required.

While carrier mobility $\mu$ measures how fast carriers can travel under an electrical driving force, carrier diffusion length $L$ determines how far carriers can travel without the driving force. $L$ can be calculated with known carrier lifetime $\tau_r$ and diffusion coefficient $D$ as $L = \sqrt{D\tau_r}$. Due to random scattering motion, carrier diffusion is usually much slower than the carrier drift process driven by an electric field. Consequently, carrier diffusion actually plays a
more important role in determining some key properties of tradi-
tional p-n junction based opto-electric devices, such as the
response rate of photodiodes, and the efficiency of LEDs and pho-
tovoltaics. Recently, lateral graphene/hBN heterostructures have
been synthesized, an important step towards developing atomi-
cally thin planar integrated circuitry [7,8]. Two dimensional tran-
sistor with the lateral graphene/hBN/graphene structure has been
demonstrated to exhibit an $I_{on}/I_{off}$ ratio larger than $10^4$, overcoming
the main drawback of the current graphene transistor [9]. Another
type of combination of graphene with 2D materials is the van der
Waals (vdW) heterostructures, where graphene is bonded to a thin
film of transition metal dichalcogenides (TMD) by the vdW force
and shows ultrafast electron transfer and strong interlayer coupling
between graphene and TMD [10]. On the platforms of the afore-
mentioned heterostructures, carrier diffusion in graphene becomes
very important. Due to the huge difference in resistance between
the hetero-junction and the graphene, almost all the applied
voltage is exerted on the junctions or the stack area such that
carrier transportation in the graphene region outside the junction
or far away from the stack area mainly relies on the diffusion
process. Therefore, the carrier diffusion property in graphene turns
out to be a key parameter that determines the performance of future
electronic devices based on graphene/2D material heterostructures.

Carriers diffusion lengths of semiconductors are usually measured
via Electron-beam-induced current (EBIC) [11], light-
induced current (LIC) [12], or from spectral response data [13].
EBIC and LIC also require deposition of electrodes, which is
intrinsically invasive, and their sensitivity and accuracy are highly
affected by electrical contact resistance and the capability to detect
small current signals. Determination of carrier diffusion length is
usually performed by two methods: one with grating and the other
without grating. In principle, the former requires electrode deposition
or optical mask-modulation approach, whereas the latter needs to
measure the sample response rate of photodiodes, and the ef-
nient p-n junction based opto-electronic devices, such as the
carrier lifetime ($\tau_c$), diffusion coefficient ($D$), diffusion length ($L$)
and mobility ($\mu$) in CVD-grown and exfoliated mono- and mul-
tilayer graphene non-invasively. In monolayer graphene,$D$—10,000 cm$^2$/s and $\mu$—120,000 cm$^2$/Vs have been observed, both
of which decrease drastically in multilayer graphene, indicating that
the remarkable transport properties in monolayer graphene origin-
ate from its unique Dirac-Cone energy structure. Mobilities of
photoexcited carriers measured here are several larger than the
Hall and Field-Effect mobilities reported in literature ($<15,000$ cm$^2$/
V), due to the high energy of photoexcited carriers. Our results
indicate the importance of obtaining monolayer graphene to realize
high-performance graphene devices, as well as the necessity to use
transport properties of photoexcited carriers for predicting the
performance of graphene-based opto-electronics.

2. Experimental section

Our new technique is inspired by the grating-mask technique
but avoids the shortcomings from sample-grating contact. As
shown in Fig. 1, pump and probe beams overlap at a same spot
on the sample (photomask), whose reduced scale image is formed by
an objective lens onto the sample plane, so that the intensities of
pump and probe spots are modulated to be in the grating pattern. As a result, an initial carrier density with a spatial
profile is generated by the pump pulse. And the probe pulse
only detect the excited carriers in the illuminated area, which
will decay due to both electron-hole recombinaton and ambipolar carrier diffusion from the illuminated area to the unillu-
mated area. Therefore, by measuring the time-resolved trans-
mission change of probe ($\Delta I$), information of both carrier
recombination ($\tau_r$) and carrier diffusion ($D$) processes is obtained.
Carrier recombination lifetime $\tau_r$ can be easily acquired from
the conventional pump-probe experiment [15,17] by simply removing
the grating. A model based on diffusion equation and the relation
between differential transmission $\Delta I$ and carrier density needs to
be derived to extract diffusion coefficient $D$.

There are several advantages in this method. First, the strong
transmission change of probe beam, instead of the weak diffraction,
is collected as signal. Second, only two measurements (with and
without grating) need to be performed to retrieve transport pa-
rameters. Third, unlike the electrical measuring techniques which
requires electrode deposition or optical mask-modulation approach, the sample here is free of any undesired contact. The
above features make the technique sensitive, simple, and truly non-
destructive. A key parameter for this technique to work effectively
is the ratio $R$ of diffusion length $L$ to image slit width $w_s$, i.e. $R = L/ w_s$. The smallest image slit width $w_{smin}$ that can be obtained in our
setup is 0.61 μm. The numerical aperture $N.A.$ is 0.4, and the typical
working wavelength of Ti:Sapphire laser oscillator is 800 nm. Thus
in principle, $w_{smin}$ in the system is 1.2 μm. If $R < 0.1$ is set to be the
failure criterion, then the technique should be able to detect the
diffusion effect originating from a diffusion length short to 120 nm
(see supplementary information for determination of the sensi-
tivity of the technique).

Four graphene samples are studied here. One of them is ob-
tained by mechanical exfoliation with Scotch tape [29], two of them
are CVD grown on copper foil, and then transferred to quartz
substrate (see supplementary for details), the fourth one is bilayer
obtained by stacking two CVD grown monolayers. By using atomic
force microscope (AFM) and Raman spectroscopy, we have deter-
dined that the exfoliated sample has 18 layers with ~6 nm thick-
ness (Fig. S2), the multilayer CVD sample has 12 layers with ~4 nm
thickness (Fig. S1), and another CVD sample is monolayer with single Lorentzian shape of 2D peak and large 2D/G peak ratio in the
Raman spectrum (Fig. S4). The bilayer character of the stacked sample is confirmed by Raman spectrum, with 2D/G peak ratio close to 1 and a wider 2D peak than the monolayer (Fig. S5). The AFM and Raman mapping data also show good uniformity of our samples (Figs. S1–S3). Fig. 2(a–c) shows ultrafast transmission signals of 12-layer, 18-layer and bilayer samples, with two grating images of different slit widths. For monolayer graphene, only one grating slit has been used, with measurements done at various

![Diagram](image)

**Fig. 1.** Schematics of the ultrafast grating imaging technique for probing the diffusion coefficient of graphene. 800 nm laser beam generated from Ti:Sapphire oscillator, is split into a pump beam and a probe beam, both of which are spatially focused and overlapped into a 90 μm spot (diameter) on the grating. Grating images from both pump and probe beams are formed at the sample plane by an objective lens. The intensities of pump and probe beams on the sample are thus modulated as the grating pattern. The transmitted probe beams are collected by a photodetector. (A colour version of this figure can be viewed online.)

![Graph](image)

**Fig. 2.** (a) Differential transmission signal of CVD grown 12-layer graphene sample measured with ultrafast grating imaging technique at excited carrier density of 2.3 × 10¹³/cm². (b) Differential transmission signal of exfoliated 18-layer graphene sample measured at excited carrier density of 2.2 × 10¹³/cm². (c) Differential transmission signal of CVD grown bilayer graphene sample measured with ultrafast grating imaging technique at excited carrier density of 5 × 10¹²/cm². Differential transmission signal of quartz substrate is also plotted. (d) Differential transmission signals of CVD grown monolayer graphene measured with grating imaging technique at three excited carrier densities. The solid lines are the fitted curves to the experimental data based on the model described in the text. (A colour version of this figure can be viewed online.)
pump fluences, as shown in Fig. 2(d). Both pump and probe pulses have 800 nm center wavelengths, 500fs pulse widths and 80 MHz repetition rates. The diameters of pump and probe spots on sample surface are 90 μm. All graphene samples display a positive peak followed by a negative recovery part. While the positive peak originates from a decrease in the interband conductivity due to state filling of un-thermizedalized electrons, the negative signal reflects the increase in the intra-band conductivity due to the free carrier absorption [20,21,30]. The values of positive peaks are the same with and without grating, showing that the effective excited carrier densities in the illuminated area are the same. However, compared to the no-grating case, the magnitudes of negative peaks with gratings are smaller, and the narrower the grating slit is, the smaller the peak. This phenomenon reveals the carrier diffusion effect in graphene. Due to the rule of intra-band transition, the magnitude of the negative signal is qualitatively correlated with the free carrier density N and the electron temperature T_e. With gratings, carrier diffusion from the illuminated area to the dark area leads to faster decays of N and T_e in the illuminated (probed) area than that in the no grating case, and consequently, magnitudes of negative peaks become smaller compared to the no grating case. In addition, with narrower grating slit, contribution to carrier decay from the diffusion process increases, which results in further decrease of the negative signal. Note that in Fig. 2(c), differential transmission signal of the quartz substrate is also plotted. Compared with graphene, the substrate has negligible signal, which confirms that the transient data purely reflects carrier dynamics in graphene.

3. Modeling

In order to extract the ambipolar diffusion coefficient D from the transient transmission signals, we modified the dynamic differential optical conductivity model [23] by taking the diffusion effect into account. In the dynamic optical conductivity model, the differential transmission signal ΔT/T_0 for graphene sandwiched by two dielectric medias is proportional to the negative value of the differential real part of optical conductivity Δσ = (σ - σ_0) [21]:

\[
\frac{ΔT}{T_0} = -(σ - σ_0)
\]

The real part of the optical conductivity can be written as [15,30]:

\[
\frac{σ}{σ_Q} = \frac{4k_T^2e}{\pi\hbar} \left[ \ln \left( 1 + e^{E_F/k_BT_e} \right) + \ln \left( 1 + e^{E_F/k_BT_e} \right) \right] \frac{1/τ_m}{\omega^2 + 1/τ_m^2} + \frac{1}{2} \left[ \tanh \left( \frac{h\nu - 2E_F}{4k_T^2e} \right) + \tanh \left( \frac{h\nu - 2E_F}{4k_T^2e} \right) \right] F(\nu/k_T, E_F/k_BT_e)
\]

where σ_Q is the universal quantum conductivity (different from the unexcited one σ_0), T_e is the electron temperature, E_F(E\_F) is the electron (hole) Fermi energy, and τ_m is the momentum scattering time. It can be seen from Equation (1) and Equation (2) that transient transmission signal is explicitly related to Fermi energy and electron temperature, both of which are associated with carrier density. Therefore, we first calculate transient carrier density excited by the pump pulse by solving the carrier diffusion-recombination equation:

\[
\partial N_e(r,t)/\partial t = D∇^2 N_e(r,t) - N_e(r,t)/τ_f
\]

When there is no grating, only the second term on the right hand matters and the solution of Equation (3) is just an exponential decay with a carrier lifetime τ_f: When there is grating, carrier diffusion (the first term) takes effect, resulting in a faster decrease of carrier density in the illuminated area. With grating, considering the initial condition as the excitation with a Gaussian beams modulated by a square wave, Equation (2) can be solved numerically to obtain the carrier density evolution in space and time N_e(r,t).

Without grating, electron temperature T_e simply follows a decaying bi-exponential function due to energy transfer from hot carriers to optical phonons and acoustic phonons (lattice) [19,22,31]: T_e(t) = T_0 + (T_{max} - T_0)exp(-t/τ_{op}) + (T_1 - T_0)exp(-t/τ_{ap}), where T_0 is initial lattice temperature (300 K), T_{max} denotes the maximum electron temperature when the excited carriers just finish thermalization, T_1 denotes the equilibrium temperature between the electron system and the optical phonon system, and τ_{op} and τ_{ap} are the times for energy transfer from hot electrons to optical phonons and acoustic phonons (lattice), respectively. T_{max} and T_1 can be calculated from the energy conservations within the electron system and within the coupled electron-optical phonon system, respectively [15,30,32]; With grating, the electron temperature will also decay faster due to electron diffusion (energy dissipation) from the illuminated area to the dark area. Considering that the electron-optical phonon scattering time τ_{op} in graphene is about tens of fs [16,19,33], within such a short time, electron diffusion has little effect on T_e. Therefore, even with grating, the maximum electron temperature T_{max}, the electron-optical phonon equilibrium temperature T_1, and the cooling time to optical phonons τ_{ap} are expected to be the same as the no-grating case. The only parameter affected substantially by the diffusion effect is the cooling time to acoustic phonons τ_{op}. So for the case of grating, the dynamic of T_e is: T_e(t) = T_0 + (T_{max} - T_0)exp(-t/τ_{op}) + (T_1 - T_0)exp(-t/τ_{ap}), with τ_{ap} being the modified cooling time due to diffusion.

Since electrons in graphene obey Fermi distribution, the time-dependent Fermi energy E_F(t) is determined from N_e(r,t) by Fermi integral relation in momentum space: E_F(t) = \frac{4}{d}\int d k \frac{1}{2\pi} \int \left[ \frac{1}{1 + exp(\hbar v/k_T E_F/k_BT_e)} \right] d(k_x d(k_y (1/2\pi)^2 / (1 + exp(\hbar v/k_T E_F/k_BT_e)/k_T T_e))), where k is electron(hole) wave vector, and v is the Fermi velocity of electrons in graphene [30]. Thus, by substituting E_F(t) into Equation (2) and using the unchanged parameters such as T_{max}, τ_{ap}, and T_1 obtained from the no grating case, our modified differential optical conductivity model can be applied to fit the transient transmission signals ΔT/T_0 with D and τ_{ap} as two fitting parameters.

4. Results and discussion

4.1. Fitted results

Fitted curves of transient transmission signals with Equation (2) are presented as solid curves in Fig. 2. It can be seen that for both cases with and without grating cases, experimental data can be well fitted with our model. In the CVD grown 12-layer sample, the fitted values for the no grating case agree well with values reported in literature: τ_f = 0.68/0.5 [33] / 1.3 [15], τ_{op} = 0.5 [16] ps, τ_{ap} = 3.3 [15,5,18,4] fs, τ_{ap} = 79.6 < 100 [33,80-100 [16], 70 – 120 [19] fs, and τ_{ap} = 1.13 [13,0.72-0.86 [16], 0.4 - 1.7 [19] ps]. With gratings, our fittings yield D = 210 ± 271 cm^2/s, τ_{ap} = 870 ± 696 fs for 1.5 μm grating slit and D = 1901 ± 245 cm^2/s, τ_{ap} = 777 ± 436 fs for 2.0 μm grating slit. For both grating slits, τ_{ap} is indeed smaller than τ_{ap} obtained for the case without grating, confirming the physical picture that electron diffusion also carries energy out of the illuminated area and makes the energy dissipation faster. Considering the uncertainties from both experiments and the fitting model, two fitted coefficients D with two slits are slightly different, but still in
the same range, indicating self-consistence of our experimental technique and numerical modeling. The same fitting procedure is performed for the exfoliated 18-layer graphene and the bilayer CVD grown sample, as shown in Fig. 2(b) and (c), respectively. The fitting yields: \( D = 3489 \pm 397 \text{ cm}^2/\text{s} \) for 1.5 \( \mu \text{m} \) grating slit and \( D = 3609 \pm 185 \text{ cm}^2/\text{s} \) for 2.0 \( \mu \text{m} \) grating slit, for the 18-layer graphene; and \( D = 4451 \pm 423 \text{ cm}^2/\text{s} \) for 1.5 \( \mu \text{m} \) grating slit and \( D = 4067 \pm 386 \text{ cm}^2/\text{s} \) for 2.0 \( \mu \text{m} \) grating slit for the bilayer graphene. For the CVD grown monolayer sample, we measured \( D \) at various excited carrier densities from 3.75 \( \times \) 10^{12}–21.2 \( \times \) 10^{14} \text{ cm}^2/\text{s}, three of which are shown in Fig. 2(d).

The fitted values of \( D \) in the CVD grown monolayer sample are plotted in Fig. 3 as a function of carrier density. Within our measured range of laser fluences, \( D \)s do not show obvious dependence on carrier density. In fact, there are three major carrier scattering mechanisms in graphene supported with substrate: scattering with acoustic phonons in graphene, Coulomb scattering with ionized impurities, and scattering with phonons in substrate. When ionized impurity scattering dominates, carrier mobility and the diffusion coefficient in monolayer graphene are almost constant with carrier density [43,53]. As shown in Fig. 3, the diffusion length of our CVD grown monolayer graphene is estimated with the formula \( L = \sqrt{Dt} \). Since \( \tau_c \), only decreases slightly with carrier density (Fig. S7), the derived diffusion length is almost constant with carrier density, with a value about 1.4 \( \mu \text{m} \). Although graphene has a remarkable diffusion coefficient as compared with traditional semiconductors with non-zero bandgap such as Si (\(<36 \text{ cm}^2/\text{s}\) for electrons [36]) and GaAs (\(<200 \text{ cm}^2/\text{s}\) for electrons [37]), the carrier lifetime in graphene (~1 ps) is several orders of magnitude shorter, which adversely limits the diffusion length in graphene to be in the order of \( \mu \text{m} \), much shorter than those in traditional semiconductors (Si: 100–300 \( \mu \text{m} \), GaAs: tens of \( \mu \text{m} \) [38]). The diffusion length obtained here unveils the spatial scale of carrier diffusion in the CVD grown graphene, providing a useful reference for designing future graphene-based opto-electronic devices where ambipolar carrier diffusion would take place.

4.2. Discussion

In literature very few direct measurements of the carrier diffusion coefficient of graphene have been reported. Table 1 summarizes the measured \( D \)s in graphene prepared with different synthesis methods and on various substrates. In Refs. [24], \( D \) were measured with spatial scanning microspectroscopy, with both pump and probe lasers at 800 nm wavelength. The first observation is that the \( D \) in monolayer samples is several times larger than those in fewlayer and multilayer samples, despite different synthesis methods, substrates and measurement techniques. According to microscopic statistic theory, the carrier diffusion coefficient can be calculated as:

\[
D = \left( \frac{k_b T \mu}{q} \right)^2, \quad \text{where } k_b \text{ is the electron momentum, } T \text{ is the temperature, } \mu \text{ is the electron effective mass, and the bracket } \langle < > \text{ means averaging over } k \text{ [39].}
\]

For all the measured \( D \)s presented in Table 1, both pump and probe pulses have wavelengths at 800 nm, hence similar distributions of electron momentum are expected. For CVD grown samples, our fitting results show that \( \tau_m \) of the multilayer (~3 fs) and bilayer (~2 fs) are larger than that of the monolayer (~1 fs) (Fig. S8). \( \tau_m \) reflects the effect of scattering on carriers. In the multilayer sample, the inner layers are protected from the charged impurity scattering at SiO\(_2\) interface [4], which results in longer scattering time. Since \( \tau_m \) tends to produce a larger \( D \) in multilayer sample, it cannot explain the trend observed in Table 1. Another parameter that can play an important role is the effective mass \( m^* \) [39]. In monolayer graphene, the energy band has a unique Dirac cone structure, and consequently, the electrons near the Fermi level are nearly massless, \( m^* \approx 0 \). In the bilayer or multilayer graphene, the energy structure is affected and becomes a wider paraboloid around the K (K’) point due to interlayer coupling [40–42], which results in a finite effective mass around K (K’) point [43]. Larger average effective mass in bilayer and multilayer graphene even rivals the counter effect from \( \tau_m \) and brings about smaller \( D \) compared to the monolayer graphene. Actually, this effective mass variation mechanism has been proposed [44–46] and can be used to explain the layer number dependence of Hall and Field-Effect mobility \( \mu \) measured in graphene [44–49].

The second observation from Table 1 is that \( D \) measured in the exfoliated multilayer sample is much larger than that in the CVD grown multilayer sample, on the same substrates and with similar number of layers. Since these two samples have similar layer numbers and substrates, it is reasonable to expect that scatterings with intrinsic acoustic phonons and with substrate phonons are similar in both of them. The observed difference in \( D \)s very likely comes from the difference in impurity scattering. Multilayer graphene exfoliated from high-quality natural graphite usually has much less impurities, while CVD grown graphene usually has many growth-induced defects and impurities, such as the disrupted sp\(^2\) bond of point defects and grain boundaries [50,51], and the chemical residue [52]. Therefore, it is reasonable to expect a higher defects concentration in CVD grown multilayer graphene and thus a smaller \( D \). The 50-layer thermally reduced graphene has the lowest \( D \) among all samples, which could result from a combined effect of layer number and high impurity concentration [53].

Using the Einstein relation, \( D = k_b T_e \mu / q \), the hot carrier mobility \( \mu \) of our three CVD samples are estimated with measured \( D \), shown as the red dots in Fig. 4. \( T_e \) is the average electron temperature calculated from our model, 750 K, 650 K, and 650 K for monolayer, bilayer and multilayer graphene, respectively (Fig. S6). For comparison, reported values of Hall mobility and Field-Effect mobility in exfoliated graphene on SiO\(_2\)/Si substrates are also plotted in Fig. 4, against layer number. All the measured mobilities show strong dependence on layer number. Interestingly, substantial decrease is only observed between monolayer and bilayer graphene, while the difference among bilayer and other multilayer graphene is not as obvious. This observation supports that the exotic electronic properties of monolayer graphene are mainly due to its unique 2D band structure, which could not be achieved in multilayer graphene. Another striking feature shown in Fig. 4 is
Table 1  
Carrier diffusion coefficients of graphene samples prepared with different synthesis methods and on various substrates.

<table>
<thead>
<tr>
<th>Synthesis method</th>
<th>CVD</th>
<th>Epitaxial</th>
<th>CVD</th>
<th>Exfoliated</th>
<th>CVD</th>
<th>Thermally reduced</th>
</tr>
</thead>
<tbody>
<tr>
<td>Layer No.</td>
<td>1</td>
<td>1</td>
<td>2</td>
<td>18</td>
<td>12</td>
<td>50</td>
</tr>
<tr>
<td>Substrate</td>
<td>quartz</td>
<td>SiC</td>
<td>quartz</td>
<td>quartz</td>
<td>quartz</td>
<td>quartz</td>
</tr>
<tr>
<td>D (cm²/s)</td>
<td>10,000</td>
<td>10,000</td>
<td>4250</td>
<td>3500</td>
<td>2000</td>
<td>1300</td>
</tr>
<tr>
<td>This work</td>
<td>Ref. [24]</td>
<td>This work</td>
<td>This work</td>
<td>This work</td>
<td>Ref. [24]</td>
<td></td>
</tr>
</tbody>
</table>

Fig. 4. Carrier mobility as a function of graphene layer number. The triangles are reported Hall mobility and Field-Effect mobility. The red dots are the hot carrier mobility deduced from our experimental data using the Einstein relation $D/\mu = k_B T_e/q$. (A colour version of this figure can be viewed online.)

that, hot carrier mobility deduced from optical measurement (~36,000 cm²/V for multilayer graphene, ~72,000 cm²/V for bilayer and ~120,000 cm²/V for monolayer graphene) are an order of magnitude larger than Hall Mobility and Field-Effect mobility. The distinct difference between the optically measured and the electrically measured mobilities has also been reported in epitaxial graphene on SiC in Ref. [24] and CVD grown graphene on SiO₂ in Ref. [25]. Our measured $D_s$ in graphene supports that ionized impurity scattering dominates carrier scattering process in graphene, which has also been demonstrated in the resistivity measurement of graphene Field-Effect transistors [1]. Ionized impurities can gradually deviate the charged carrier trajectory by Coulomb potential and the scattering cross section $\sigma$ is inversely proportional to the square of charged carrier energy $E$: $\sigma \propto 1/E^2$ [54]. In un-doped non-degenerate semiconductors, mobility due to ionized impurity scattering has a temperature dependence of $-T_e^{-3/2}$ [5]. Since photoexcited carriers have much higher energy than electrically excited ones, the scattering cross section of photoexcited carriers due to ionized impurities is expected to be much smaller, which brings about a larger mobility measured in this work than Hall mobility and Field-Effect mobility.

Our results have several important implications: a) Layer-number dependence, mainly the difference between quadratic energy structure in multilayer graphene and the linear energy structure in monolayer graphene, has significant influence on carrier transport properties. To realize high-performance graphene devices, synthesis of true mono-layer graphene is indispensable. b) Charged impurity scattering dominates in both monolayer and multilayer samples. c) Transport properties of photoexcited hot carriers are remarkably different from that of electrically induced room-temperature carriers. When evaluating performance of graphene-based opto-electronics, it is necessary to use transport properties of photoexcited carriers, instead of room-temperature ones.

5. Conclusion

An ultrafast grating imaging technique has been utilized to measure transport properties ($\mu$, $I$, $D$) of photoexcited carriers in graphene. All the transport properties do not show obvious dependence on carrier density, which supports the fact that ionized impurity scattering dominates the carrier scattering process in graphene. $D$ and $\mu$ show drastic decrease from monolayer to multilayer samples, which was attributed to the unique Dirac Cone energy structure in monolayer graphene. The measured mobilities of photoexcited carriers are several times larger than that of Hall and Field-Effect mobilities, due to the much higher carrier energy of optically excited hot carriers. Our results indicate the importance of obtaining monolayer graphene to realize high-performance graphene devices, as well as the necessity to use transport properties of photoexcited carriers for predicting the performance of graphene-based opto-electronics.

Acknowledgment

The authors are grateful for the support from National Science Foundation (CARER, Grant No. CBET-1351881, and NASCENT, Grant No. EEC-1160494). T. S. Lai also acknowledges the support from National Basic Research Program of China under Grant No.2013CB922403, National Natural Science Foundation of China under Grant Nos. 11274399 and 61475195, Natural Science Foundation of Guangdong Province under Grant No.2014A030311029.

Appendix A. Supplementary data

Supplementary data related to this article can be found at http://dx.doi.org/10.1016/j.carbon.2016.05.075.

References
